

DOCKET NO: 216932US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
MASAKI YAMADA, ET AL. : EXAMINER: MANDALA, VICTOR A.
SERIAL NO: 10/003,114 :
FILED: DECEMBER 6, 2001 : GROUP ART UNIT: 2826
FOR: SEMICONDUCTOR DEVICE :
HAVING BURIED CONDUCTIVE LAYER
FORMED IN AN INSULATING LAYER
AND METHOD OF MANUFACTURING
THEREOF

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 25, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.